

Test Mass Substrate Material Selection for Advanced LIGO: An Update from the Optics Working Group




David Reitze
UF
for the OWG



Test Mass Material Selection

- At the LSC meeting, Livingston, LA, March 2004:

| | |
|--|---|
|  LASER INTERFEROMETER GRAVITATIONAL WAVE OBSERVATORY RECORD OF DECISION/AGREEMENT (RODA) | |
| Document | LIGO-M040020-00-Y |
| Date: | 27 Jan 2004 |
| Title: | RODA: Sapphire/fused silica downselect date |
| To the Attention of: | COC: GariLynn Billingsley, Bill Kells, Helena Armandula, Gregg Harry SUS: Ken Strain, Norna Robertson, Janeen Romie, Mark Barton, Justin Greenhalgh, Caroline Cantley, Calum Torrie, Jim Hough TNI: Eric Black, Ken Libbrecht AOS: Phil Willems, Dave Ottaway, Mike Smith Systems: Peter Fritschel, Dennis Coyne, David Shoemaker |
| cc: | aligo_systems, aligo_sus |

- Date for selection: June 30, 2004

June 30th has passed; where are we?

- Deadline driven by intimate link between optics and suspensions
 - » Physical dimensions of test mass material different for sapphire and fused silica
 - » Test mass size difference affects quad suspension design
 - Must fix size to move design forward (and keep UK funding synchronized...)
- Do we have enough information to make a *good* decision? We always want more...
 - » Very active R&D programs in sapphire and silica still producing important results
 - » Link between substrate and coating performance made clear over last two years; leads to a more complex decision
- Agreement between SUS and OWG to push back decision
 - » Not a problem given current AdL funding and construction schedule

Down Selection Participants

- LSC Participants

- » Helena Armandula, Gari Billingsley, Eric Black, Jordan Camp*, Dennis Coyne, Marty Fejer*, Sam Finn*, Peter Fritschel*, Gregg Harry, Jim Hough*, Steve Penn, Dave Reitze, Roger Route, Norna Robertson, Shiela Rowan, Peter Saulson*, David Shoemaker**, Phil Willems*

* DS committee member, **DS chair

- Industrial Partners/Contributors

- » Chandra Khattak (Crystal Systems, sapphire), Jean-Marie Mackowsky (SMA Virgo, coatings), Roger Netterfield (CSIRO, coatings)

LIGO Sapphire Test Mass Requirements

P. Fritschel, et al., LIGO T010075-00; G. Billingsley, et al., LIGO-T020103-08

| | <i>Value</i> | <i>Driver</i> |
|----------------------------|----------------------------------|--|
| <i>Mass</i> | 40 kg | SQL |
| <i>Physical dimension</i> | 31.4 cm x 13 cm | density of sapphire |
| <i>Optical homogeneity</i> | < 10 nm rms* | sideband loss in RC |
| <i>Microroughness</i> | < 0.1 nm rms | 75 ppm arm cavity loss |
| <i>Internal scatter</i> | < 50 ppm (2X)* | Overall carrier loss |
| <i>Bulk Absorption</i> | < 100 ppm/cm** | Overall carrier loss; optical path distortion |
| <i>Coating Absorption</i> | < 1 ppm | 75 ppm arm cavity loss |
| <i>Thermal noise</i> | Q > 2 x 10⁸ | Sensitivity in 50-300 Hz band |
| <i>Birefringence</i> | < 0.1 rad* | Overall carrier loss |
| <i>Polish</i> | < 0.9 nm rms | 75 ppm arm cavity loss |

*ITM only **assumes active thermal compensation above ~40 ppm/cm



Fused Silica Test Mass Requirements

P. Fritschel, et al., LIGO T010075-00; G. Billingsley, et al., LIGO-T020103-05

| | <i>Value</i> | <i>Driver</i> |
|----------------------------|--|--|
| <i>Mass</i> | 40 kg | SQL |
| <i>Physical dimension</i> | 3.4 cm x 20 cm | density of silica |
| <i>Optical homogeneity</i> | < 10 nm rms* | sideband loss in RC |
| <i>Microroughness</i> | < 0.1 nm rms | 75 ppm arm cavity loss |
| <i>Internal scatter</i> | < 50 ppm (2X)* | Overall carrier loss |
| <i>Bulk Absorption</i> | < 3 ppm/cm** | Overall carrier loss; optical path distortion |
| <i>Coating Absorption</i> | < 0.5 ppm | 75 ppm arm cavity loss |
| <i>Thermal noise</i> | $Q > 1 \times 10^8$ | Sensitivity in 50-300 Hz band |
| <i>Birefringence</i> | < 0.1 rad* | Overall carrier loss |
| <i>Polish</i> | < 1.2 nm rms | 75 ppm arm cavity loss |

*ITM only

**assumes active thermal compensation

The Importance of Coatings

G. Harry, et al., LIGO-C030187-00-R

| Parameter | Sapphire goal | Sapphire requirement | Fused Silica goal | Fused Silica requirement | Currently |
|--|--|--|--|--|---|
| Mechanical loss ¹ | 2×10^{-5} * | 6×10^{-5} * | 1×10^{-5} ** | 3×10^{-5} ** | Mechanical loss: $2-3 \times 10^{-4}$ (tantala) |
| Optical Absorption ² | 0.5 ppm | 1 ppm | 0.2 ppm | 0.5 ppm | |
| Thermal expansion ³ | $5 \times 10^{-6}/K$ * | $< 2 \times 10^{-6}/K$ * $> 1 \times 10^{-6}/K$ * | $5 \times 10^{-7}/K$ ** | $< 2 \times 10^{-6}/K$ ** $> 1 \times 10^{-7}/K$ ** | |
| Birefringence ⁴ | 1×10^{-4} rad | 2×10^{-4} rad | - | - | Absorption: ~ 0.5-1 ppm |
| Scatter ⁵ | 1 ppm | 2 ppm | 1 ppm | 2 ppm | |
| Thickness uniformity ⁵ | 10^{-3} (over 21.5 cm diameter) 10^{-2} (over 33.0 cm diameter) | 10^{-3} (over 21.5 cm diameter) 10^{-2} (over 30.0 cm diameter) | 10^{-3} (over 21.5 cm diameter) 10^{-2} (over 33.0 cm diameter) | 10^{-3} (over 21.5 cm diameter) 10^{-2} (over 30.0 cm diameter) | |
| ITM HR transmission | - | 5×10^{-3} $\pm 2.5 \times 10^{-4}$ | - | 5×10^{-3} $\pm 2.5 \times 10^{-4}$ | |
| ETM HR transmission | 5 ppm | 10 ppm | 5 ppm | 10 ppm | |
| Test Mass HR matching $2(T_1 - T_2)/(T_1 + T_2)$ ⁶ | 5×10^{-3} | 1×10^{-2} | 5×10^{-3} | 1×10^{-2} | |
| AR reflectivity | - | 200 \pm 20 ppm | - | 200 \pm 20 ppm | |

Decision Criteria: Beyond the physical, optical, and mechanical characteristics...

- Primacy of the astrophysics mission of Advanced LIGO
 - » Which substrate is better suited to optimizing the number, type, and parameter estimation of detectable events?
- IFO performance - “Will it work if we choose _____?”
 - » Hard failure mode – interferometer will not operate (or operate with significant reduction in sensitivity)
 - » Soft failure mode – some reduced sensitivity, reach
- IFO Schedule – “Will there be delays?”
 - » Fabrication delays
 - » Commissioning delays
- IFO Implementation Issues → thermal compensation
- Cost – turns out to be about the same for both materials
- Fallback
 - » “If we choose substrate X and discover a nasty hard failure mode, how easily can we fall back to substrate Y?”

DS 'Methodology'

- Exchange and coordination of research through meetings and telecons
 - » Scheduled monthly OWG meetings
 - » Frequent (at least monthly, sometimes more) meetings to discuss coating R&D
- Formal 'Down-selection' telecons
 - » Define and refine selection criteria
 - » Identify gaps in knowledge
 - » Quantify risk
- Score sheet for sapphire and silica
 - » All scores have 'error bars'
 - » Some error bars are larger than others...
 - » Some things are still unknown...
- **Work Product → recommendation to the LIGO Lab management (who will make the final decision)**

Astrophysics Selection Criteria

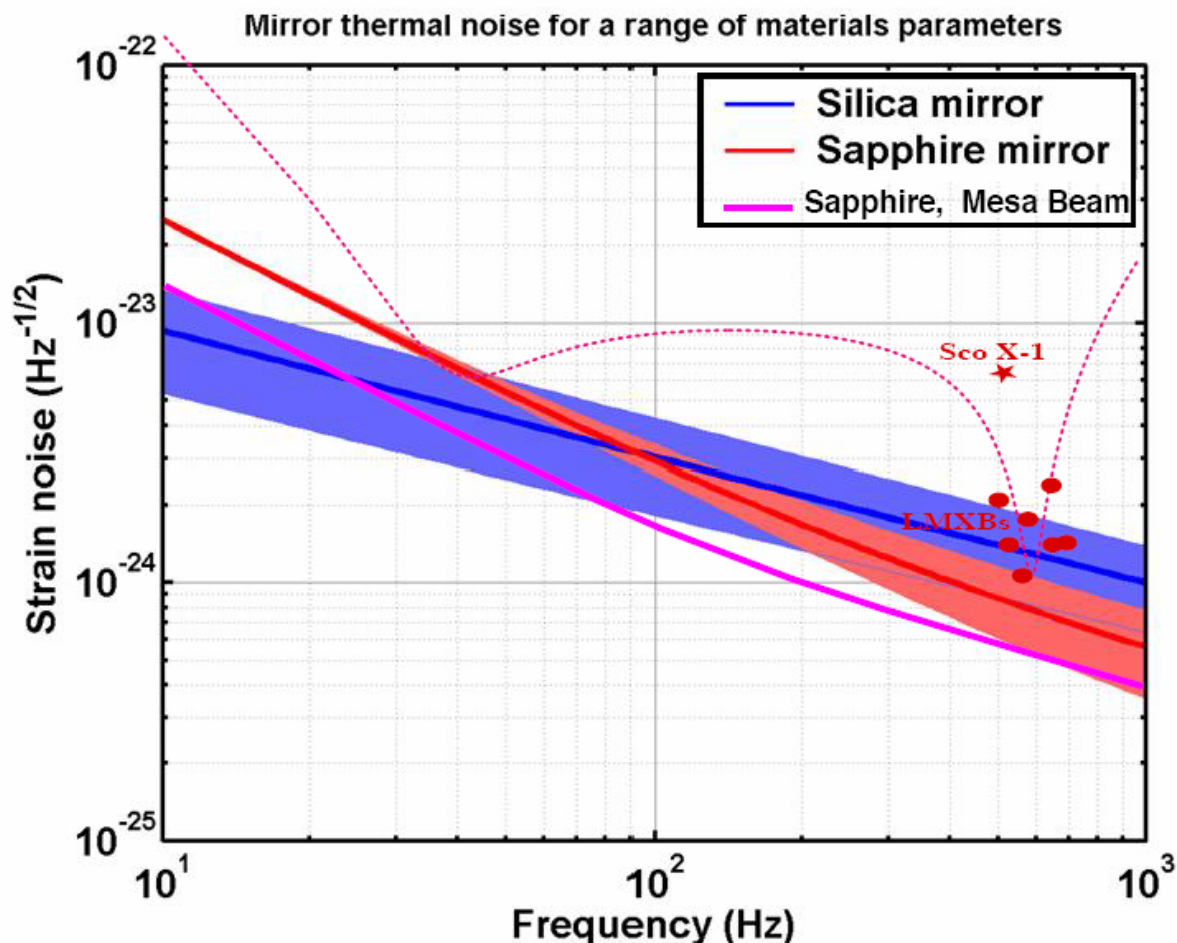
G. Harry, D. Shoemaker, MIT

- Different sources → different performance metrics for sapphire and fused silica →
 - » NS-NS inspiral
 - » $10 M_{\odot}$ BH-BH merger
 - » Accreting low mass X-ray binary source near 700 Hz
(Bildstein, arXiv:astro-ph/0212004)
 - » Stochastic background
- Evaluate on Bench 2.1
 - » Consider optimistic, pessimistic, and baseline TM parameters
 - » Normalized performance dependent on event type
 - Inspirals, mergers, XRB → $(2 \cdot \text{Range}_{\text{subX}} / \Sigma \text{Range})^3$
 - Stochastic → $\text{Log}(\Omega_{\text{subX}} / \Omega_{\text{subY}})$
 - » Equal weighting for events

Thermal Noise Performance: LMXBs

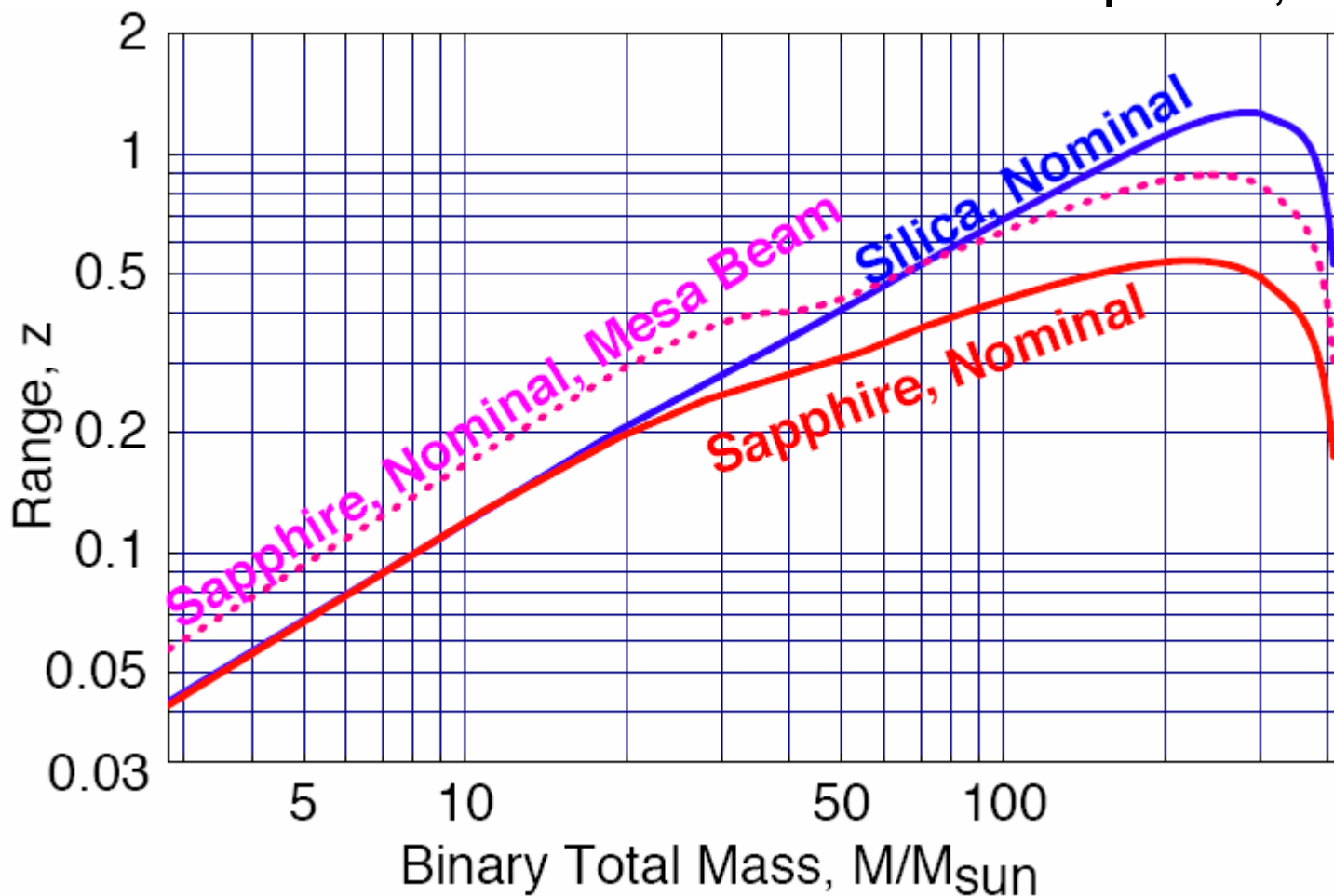
P. Fritschel, G. Harry, MIT
Kip Thorne, CIT

- FS has better low frequency performance
 - » But more uncertainty
 - » Sapphire TE noise helped by mesa beam
- Sapphire has better high frequency performance
 - » Sapphire sees almost all LMXBs



Impact on BHBH binary searches

Kip Thorne, CIT




LIGO

Astrophysics Score Sheet

| | | | SAPPHIRE | | SILICA | | Weight |
|---|-------------|--|-----------------|-------------------|---------------|-------------------|---------------|
| | | | value | normalized | value | normalized | |
| NSNS distance (MPC) | | | | | | | |
| | baseline | | 191 | 1.00 | 191 | 1.00 | 1.00 |
| | optimistic | | 208 | 0.73 | 254 | 1.33 | 1.00 |
| | pessimistic | | 165 | 1.12 | 153 | 0.89 | 1.00 |
| 10Ms BHBH distance (MPC) | | | | | | | |
| | baseline | | 923 | 0.82 | 1052 | 1.21 | 1.00 |
| | optimistic | | 1016 | 0.52 | 1510 | 1.71 | 1.00 |
| | pessimistic | | 762 | 0.97 | 775 | 1.03 | 1.00 |
| LMXB at 730 Hz, $\times 10^{-25}$ | | | | | | | |
| | baseline | | 6.8 | 2.64 | 12 | 0.48 | 1.00 |
| | optimistic | | 4.5 | 2.20 | 7 | 0.54 | 1.00 |
| | pessimistic | | 9.6 | 2.37 | 16 | 0.51 | 1.00 |
| Stochastic background Ω, $\times 10^{-9}$ | | | | | | | |
| | baseline | | 1.7 | 0.98 | 1.2 | 1.02 | 1.00 |
| | optimistic | | 1.6 | 0.98 | 1.1 | 1.02 | 1.00 |
| | pessimistic | | 1.7 | 1.01 | 1.9 | 0.99 | 1.00 |
| Weighted astrophysical performance | | | 1.28 | | 0.98 | | |

Performance Selection Criteria

- Which substrate has the best opportunity for reaching the AdLIGO SRD sensitivity?
- Risks for sapphire
 - » Growth of 15-18 large blanks with average absorption < 100 ppm/cm and absorption fluctuations < 0.25 mean absorption
 - » Not as much known about coatings on sapphire
 - Adhesion, absorption
 - » Thermal noise from differential thermal expansion between silica bonding ears and sapphire flats
- Risks for Silica
 - » Mechanical loss not yet completely understood for large substrates
 - » Coating absorption inhomogeneities \rightarrow thermal compensation challenge
- Risks for both
 - » Parametric excitation of mirror Stokes modes by laser

Performance Score Sheet

- Fused silica 1.5x more likely to 'perform'
- Stokes instability – how important?

V.B. Braginsky, et al., Phys. Lett. (2001).

| | Sapphire | Silica |
|---|-----------------|---------------|
| fabrication of satisfactory substrates | 0.85 | 0.98 |
| polishing, also sides | 0.77 | 0.93 |
| coating, also adhesion | 0.8 | 0.85 |
| bonding suspension 'ears' | 0.85 | 0.92 |
| managing Stokes instability | TBD | TBD |
| electrostatic charging | 0.85 | 0.9 |
| PRODUCT of success measures | 0.52 | 0.77 |

Schedule Perspective

- Evaluation of 'schedule slippage' risk
- Vendor delays
 - » Sapphire crystal growth
 - » More difficult to polish sapphire to required tolerances; more steps involved (compensating polish)
 - » Sapphire may require high temperature annealing
 - » Coating adhesion on sapphire
- Assembly delays
 - » Bonding ears for suspension fibers
- Commissioning delays
 - » electrostatic charging

Schedule Score Sheet

- Fused silica 1.9x more likely to meet schedule
 - » Parametric instability, charging not well investigated

| | Sapphire | Silica |
|---|-----------------|---------------|
| fabrication of satisfactory substrates | 0.8 | 0.98 |
| polishing, also sides | 0.57 | 0.87 |
| coating, also adhesion | 0.98 | 0.98 |
| bonding suspension 'ears' | 0.95 | 0.95 |
| managing Stokes instability | TBD | TBD |
| electrostatic charging | TBD | TBD |
| PRODUCT of success measures | 0.42 | 0.79 |

Implementation Perspective

- How does the choice of substrate impact implementing AdLIGO IFOs?
 - » Can we fit a second interferometer at one of the sites?
 - » Suspension issues related to TM size differences?
 - » **Thermal compensation**
 - » Fallback

Implementation Score Sheet

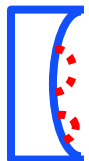
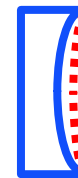
- Sapphire 4.5x better than silica
- Thermal compensation implementation critical

| | Sapphire | Silica |
|---------------------------------------|-------------|-------------|
| second interferometer at a site | 0.9 | 0.9 |
| suspension design | 0.85 | 0.9 |
| thermal compensation | 0.86 | 0.17 |
| angular instability | 0.85 | 0.9 |
| fallback to the alternative substrate | TBD | TBD |
| | | |
| PRODUCT of success measures | 0.56 | 0.12 |

Thermal Compensation

Phil Willems, CIT, Ryan Lawrence, MIT

- Implemented in LIGO I
 - » Stabilization of power recycling cavity for RF sidebands
- For AdLIGO, require **homogeneous** and **inhomogeneous** compensation
- **Homogeneous** heating: beam profile imprints $\Delta T(r)$ on mirror due to average absorption
 - » $\Delta OPD = \Delta T(r) (dn/dT) L \rightarrow$ bulk index optical path distortion
 - » $\Delta L = \alpha \Delta T(r) L \rightarrow$ surface physical distortion
 - » Compensate using a ring heater or laser (CO₂ the current choice)
- **Inhomogeneous** heating: beam profile imprints $\Delta T(x,y,z)$ on mirror due to fluctuations in absorption
 - » Compensate using a laser (CO₂ the current choice)
- Both substrate and coating absorption problematic
 - » Coating more so!



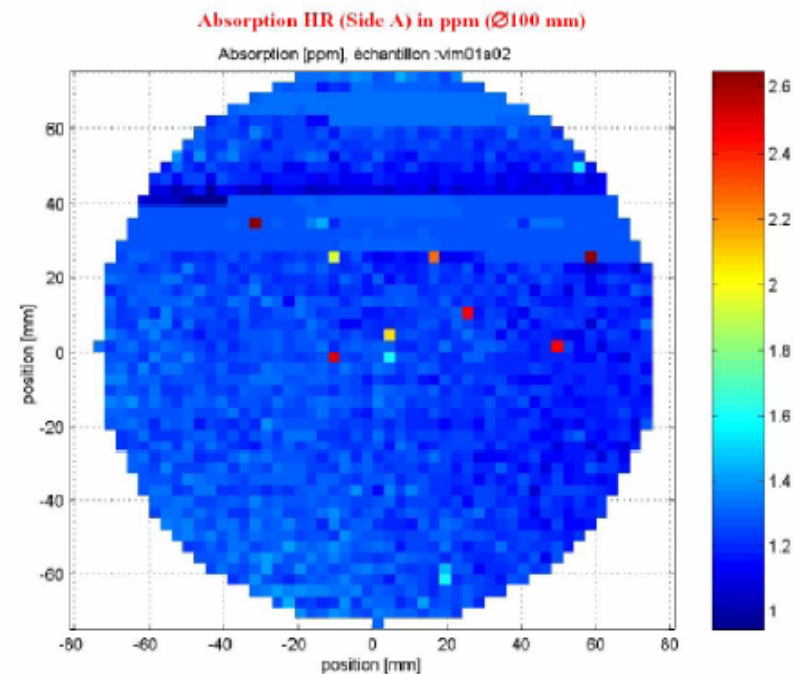
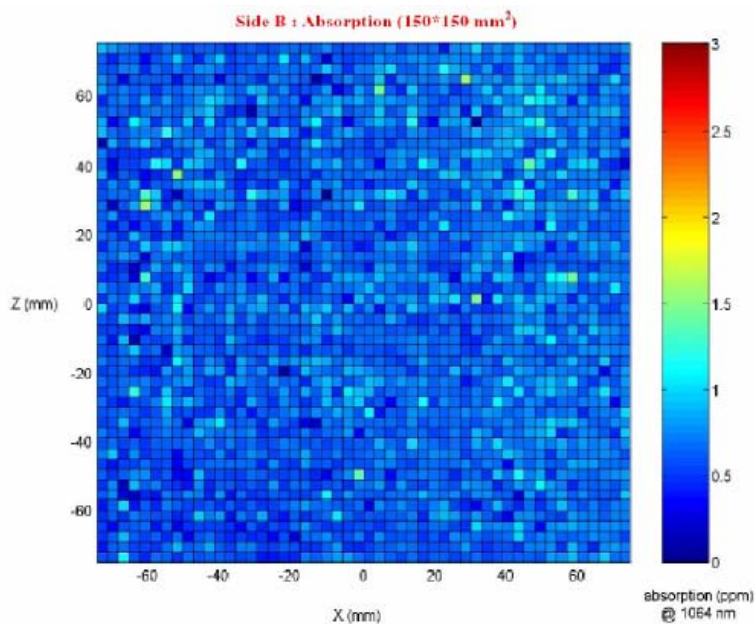
Thermal Compensation (cont'd)

Phil Willems, CIT

- Affects AdLIGO in 3 ways
- 1) Arm cavity mode and scattered power
 - a. Homogeneous → waist, spots on end mirrors are power dependent
 - i. Mode changes → sapphire = 0.9, silica = 0.8
 - ii. For laser actuation, worry about injecting noise → sapphire = 0.5, silica = 0.9
 - b. Inhomogeneous → coating absorption inhomogeneties
 - i. Not much known, but can tolerate 30 mW (I) hot spots → sapphire = 0.8, silica = 0.2

Coating Absorption Maps - Fused Silica

- SMA Virgo



Thermal Compensation (cont'd)

Phil Willems, CIT

2) RF sideband power in the recycling cavities

- RF sidebands resonate in PR, SR cavities

Thermal distortions clamp sideband power

- Silica compensable for coating absorption < 0.5 ppm
- Sapphire compensable for coating absorption < 0.5 ppm
 - Inhomogeneities cause significant problems for sapphire

sapphire = 0.8, silica = 0.6

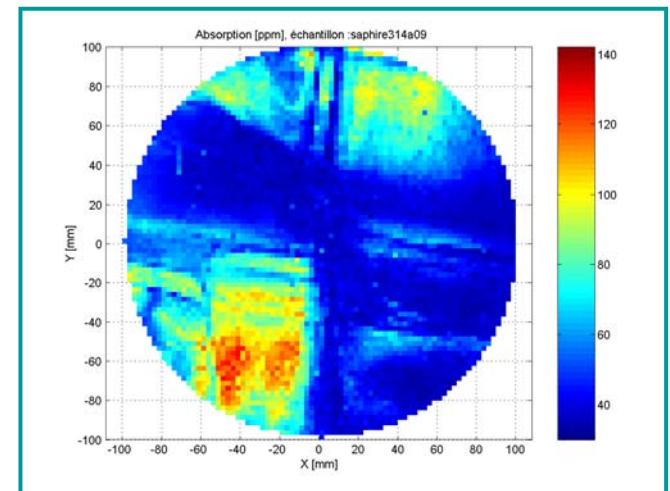
3) Efficiency of GW coupling to dark port

- GWs resonate in SR thermally distorted SR cavity
 - depends on operational mode (tuned vs detuned)
 - depends on frequency range (source)

sapphire = 0.6, silica = 0.4

Sapphire Outstanding Issues

- Absorption in large substrates:
 - » 3 pieces measured by SMA-Virgo
 - #1 (314 mm x 130 mm): 60 ppm/cm average, 30 –130 ppm/cm range
 - #2 (314 mm x 130 mm): 31 ppm/cm average, 10 – 53 ppm/cm range
 - #3 (250 mm x 100 mm): 49-55 ppm/cm average, 29 –110 ppm/cm range
- Post-growth annealing studies (Stanford)
 - » Annealing time scaling with substrate size?
 - » Does annealing smoothout inhomogeneous absorption?

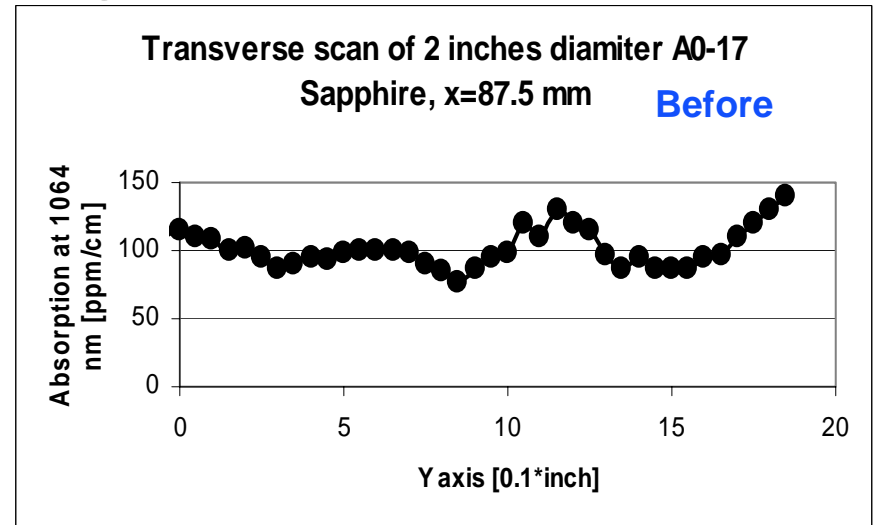
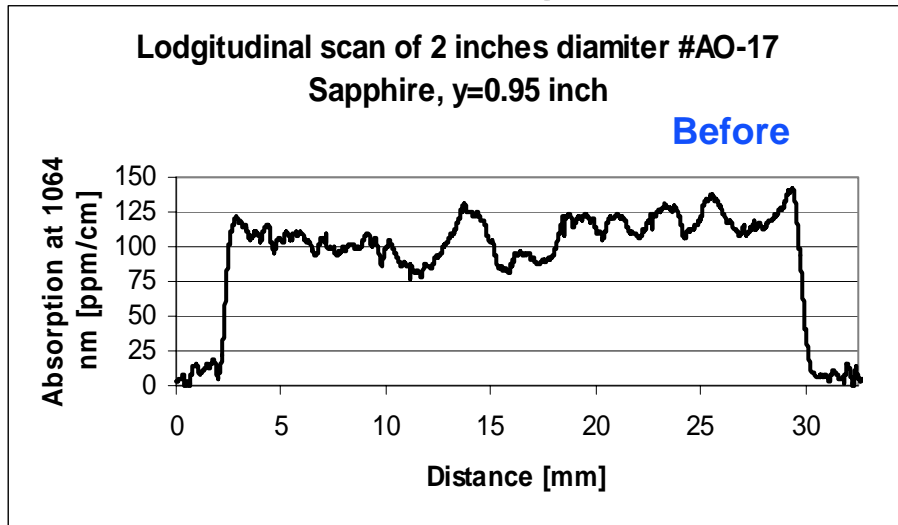


Absorption in Sapphire

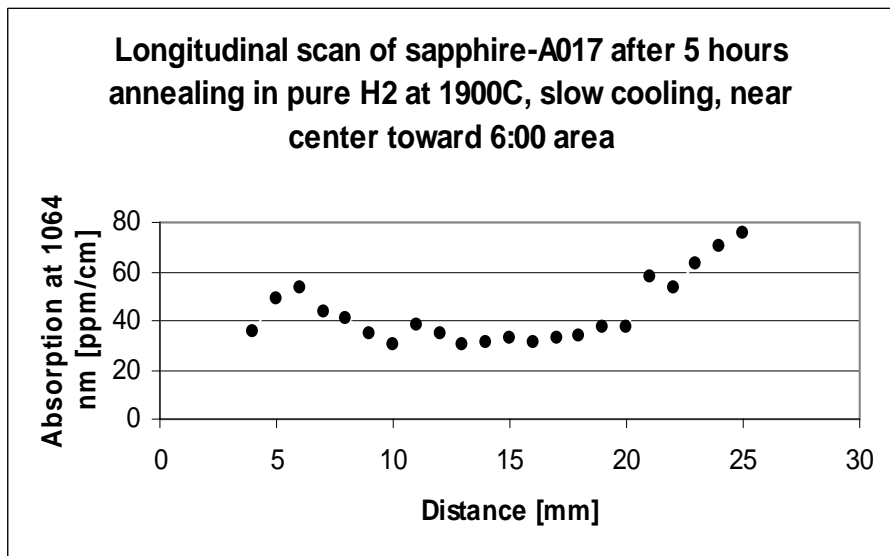
R. Route, M. Fejer, Stanford

- Investigates methods for reducing homogeneous and inhomogeneous absorption using high temperature anneal and cooling
 - » Vary T, cool down period, annealing gas
- In small samples (2" x 2"), see reductions to 10-20 ppm/ range
 - » Need to look at larger samples
- Possible evidence for 'smoothing' of inhomogeneities due to diffusion
 - » Need more statistics

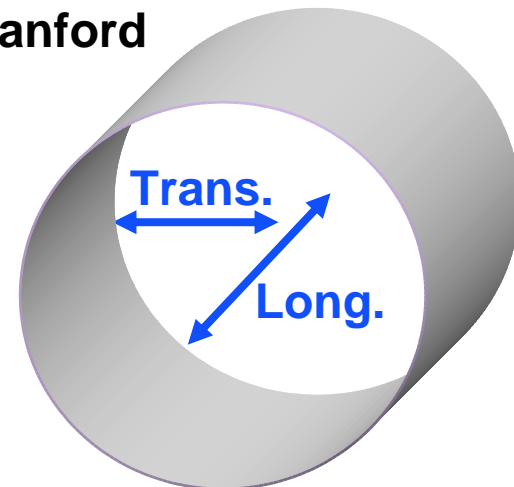
CSI-A017 sapphire cylinder – results of hydrogen-annealing at 1900°C



After



**R. Route, M. Fejer,
Stanford**



Hi-Temp. Vacuum Annealing Results

(Promising but need more data on high spatial frequency inhomogeneities and kinetics)

| ID | Start Date | Actual Temp. | Time | Heat/Cool | Ambient | Before HT | After HT | Comments | Ambient Spec. |
|---|------------|--------------|---------|-----------|-----------|-----------|----------|----------------|---------------|
| Half CSI windows, 25.4 mm dia by 12.5 mm thick | | | | | | | | | |
| 103-A | 11/10/1999 | 1198 C | 12 hrs | 310 C/hr | 0.2 CFH | 30 | 20-25 | | H2/N2 |
| 103-A | 1/22/2000 | 1800 C | 80 hrs | 800 C/hr | Hi-Vac. | 20-25 | 18 | | < E-5 Torr |
| 103-B | 11/11/1999 | 1198 C | 16 hrs | 310 C/hr | 0.2 CFH | 27-30 | 20 | | Wet H2/N2 |
| 103-B | 12/9/1999 | 1800 C | 24 hrs | 800 C/hr | Hi-Vac. | 20 | 12-15 | | < E-5 Torr |
| 103-B | 1/12/2000 | 1800 C | 42 hrs | 20 C/hr | Hi-Vac. | 12-15 | 12 | Repolish req'd | < E-5 Torr |
| 106-A | 11/11/1999 | 1800 C | 15 hrs | 800 C/hr | Hi-Vac. | 80-100 | 30-35 | | < E-5 Torr |
| 107 | 3/11/2000 | 1800 C | 100 hrs | 20 C/hr | Hi-Vac. | 80 | 40-80 | | < E-5 Torr |
| 107 | 3/16/2000 | 1800 C | 96 hrs | 20 C/hr | Hi-Vac. | 40-80 | 30-45 | | < E-5 Torr |
| 107 | 4/14/2000 | 1800 C | 100 hrs | 20 C/hr | Hi-Vac. | 30-45 | TBD | | < E-5 Torr |
| 105-T-A | 3/29/2000 | 1198C | 10 hrs | 200C/hr | 0.2 CFH | 40-55 | 27-37 | | H2/N2 |
| 105-T-A | 3/31/2000 | 1800 C | 96 hrs | 20 C/hr | Hi-Vac. | 27-37 | 12-18 | | < E-5 Torr |
| 105-T-A | 4/14/2000 | 1800 C | 100 hrs | 20 C/hr | Hi-Vac. | 12-18 | TBD | | < E-5 Torr |
| 105-T-B | 3/31/2000 | 1800 C | 96 hrs | 20 C/hr | Hi-Vac. | 45-65 | 15-17 | | < E-5 Torr |
| 105-T-B | 4/16/2000 | 1125 C | 12 hrs | 100 C/hr | 0.2 CFH | 15-17 | 15-17 | | H2/N2 |
| 105-T-B | 4/20/2000 | 1125 C | 100 hrs | 25 C/hr | 0.2 CFH | 15-17 | TBD | | H2/N2 |
| CSI a-axis cylinders, 50 mm dia by 50 mm long, Hemlite grade | | | | | | | | | |
| A227 | 6/3/2000 | 1800 C | 100 hrs | 20 C/hr | Hi-Vac. | 50-100 | 7 - 50 | Fractured | < E-5 Torr |
| AO-17 | 8/2/2000 | 1900 C | 5 hrs | 20 C/hr | ~ 0.2 CFH | 80 -140 | 30 - 80 | | Pure H2 |
| | 8/5/2000 | 1800 C | 100 hrs | 20 C/hr | Hi-Vac. | 30 - 80 | 5 - 60 | | < E-5 Torr |

Sapphire Outstanding Issues II

- Sapphire mirror coatings
 - » Coating process not as mature as fused silica
 - Adhesion
 - Microroughness
 - Cleaning surface after polishing
 - R&D effort required by vendor
- Excess noise from silica-sapphire bonding interface
 - » Differential thermal expansion
 - Stress → creaking
 - » Inhomogeneous bonds suffer more...
 - » Not much known...



Fused Silica Outstanding Issues

- Coating absorption
 - » Identified as a potentially serious problem for thermal compensation in AdLIGO
 - Homogeneous absorption: > 1 ppm 'breaks' interferometer
 - Inhomogeneous absorption: carrier arm cavity loss; sideband PRM, SRM loss

- Thermal noise in fused silica
 - » Understanding of mechanical loss
 - Large substrates
 - Frequency dependence

Mechanical Loss in Fused Silica

Steve Penn, HWS

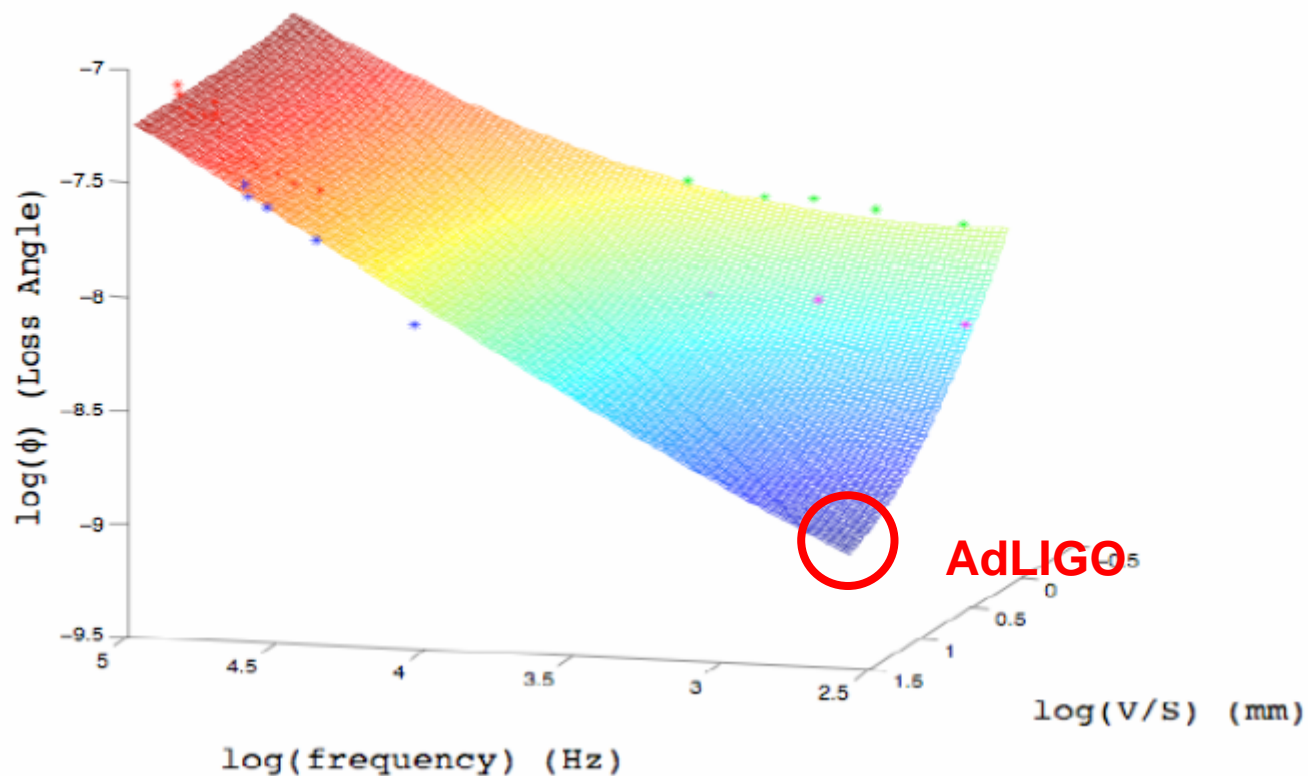
- Need fused silica $Q < 10^8$ for AdLIGO
- Salient data
 - » Syracuse group: low frequency $\phi \sim (V/S)^{-1}$
 - » Measurements on large substrates done at high frequencies (above GW band)
- Empirical model for frequency dependence of fused silica

$$\phi(f, \frac{V}{S}) = \left(C_1 / \frac{V}{S}\right) + C_2 f^{C_3} + C_4 \phi_{th}$$

Mechanical Loss in Fused Silica

Steve Penn, HWS

Summary: $\phi = 6.18e-09 \text{ (S/V)} + 7.88e-12 f^{0.77} + 0.827 \phi_{\text{th}}$



Advanced LIGO Coating Research

- Major efforts focused on:
 - » Reducing mechanical loss (thermal, thermo-elastic noise)...
 - » Reducing optical loss (coating absorption and scattering)...
 - » ... without forgetting about homogeneity, birefringence, uniformity
- Advanced LIGO R&D groups: Caltech, Glasgow
Hobart William Smith College, MIT, Stanford
- Joint R&D efforts with:
 - » CSIRO – stoichiometry, optical loss, Young's modulus of tantala
 - » SMA Virgo – doping and different coatings to reducing mechanical loss

“Coating thermal noise engineering”

Greg Harry, MIT

- Doping with Ta_2O_5 with Ti relaxes stress
- SMA-Virgo/Glasgow/MIT effort

$\lambda/4$ SiO_2 – $\lambda/4$ Ta_2O_5 Coatings with TiO_2 dopant

| <i>Dopant Conc.</i> | <i>Loss Angle</i> |
|---------------------|---------------------|
| <i>None</i> | $2.7 \cdot 10^{-4}$ |
| <i>Low</i> | $1.8 \cdot 10^{-4}$ |
| <i>Medium</i> | $1.6 \cdot 10^{-4}$ |
| <i>High</i> | ? |

Conclusions

- Selection of test mass substrate entering final phase
 - » Late by 'official schedule', nonetheless the delay has been worthwhile
- Sapphire better based on astrophysics considerations
 - » Assumes all sources are equally interesting
- Fused silica better on confidence in performance, schedule
- On cost and implementation, roughly equal except for thermal compensation
 - » **Caveat is thermal compensation; favors sapphire, but scary for both...**
- Active R&D efforts continuing in sapphire absorption, silica 'Q', coatings
- **DS meeting tomorrow 8 am**
 - » **Decision likely in the very near future**
 - » **Input solicited**

Interpretation of Score

1 = perfectly confident

0.98 = as high as we could hope

0.95 = very good rating for an individual element

0.9 = pretty confident

0.8 = marginally acceptable confidence

0.5 = a 50-50 chance that the thing will work (2x worse sensitivity, <2years delay to SRD)

0 = certain failure

LSC OWG Program Additions

- Today, SWG/OWG joint meeting, 3:30-6:30
 - » Add Erika D'Ambrosia – “Equivalence relation between non spherical optical cavities and application to advanced G.W. interferometers.”
- Tomorrow 9:00 – noon
 - » Add Hiro Yamamoto - "Effects of as-built Mirrors“
 - » Add Erika D'Ambrosia – “Flat-Top Beam Profile Cavity Prototype”
 - » Add David Jackrel – “Update on High Power Photodiode Development”